

520.39728VX1

NITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

M. HATANO, et al.

Application No.:

10/670,356

Filed:

September 26, 2003

For:

THIN FILM SEMICONDUCTOR DEVICE,

POLYCRYSTALLINE SEMICONDUCTOR THIN FILM

PRODUCTION PROCESS AND PRODUCTION APPARATUS

Art Unit:

2813

Examiner:

T. NGUYEN

PETITION FOR EXTENSION OF TIME

Commissioner for Patents **POB 1450** Alexandria, VA 22313-1450

September 19, 2005 (Monday)

Sir:

In the matter of the above-identified application, Applicants hereby respectfully petition for an extension of time to permit filing a response within a twomonth time period subsequent to expiration of the shortened statutory period set in the outstanding Office Action mailed April 18, 2005. A credit card payment form in the amount of \$450.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (Docket No. 520.39728VX1) and any excess fees credited to that account.

Respectfully Submitted,

I. TERRY, STOUT & KRAUS, LLP

Gregøry E. Montone

GEM/dks

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